S	heet	1	of	1
_	HEEL		U 1	

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (Rev. 2-32) PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. YAO-3950	SERIAL NO 09/103,873
Information Disclosure Statement by Applicant	APPLICANT Yoshihisa Nagano et al.	
(Use several sheets Recessary)	FILING DATE June 24, 1998	GROUP 2815

U.S. PATENT DOCUMENTS

		7		1			
Exmr		Document	Date	Name	Class	Sub	Filing
Initial		Number				Class	Date
100		5,561,623	10/01/1996	Ema		I .	
400		5,444,012	08/22/1995	Yoshizumi et al.			
0		5,132,774	07/21/1992	Matsuura et al. (corresponds to DE 41 00 525)			
0		5,250,468	10/05/1993	Matsuura et al. (corresponds to DE 41 00 525)			
						There pare,	
	İ				CEIV	ロ リ	<i></i>
				l / /			
				NU	W 23 19	198/	
]		
				L GH		DIAC.	
·/						-100	

FOREIGN PATENT DOCUMENTS

Exmr Initial		Document Number	Date	Country	Class	Sub Class	Translatio YES N
10		0 557 937	09/01/1993	EPO			T
N	7	0 499 433	08/19/1992	EPO			
D	e'	DE 41 00 525	08/08/1991	Germany (corresponds to U.S. Patent Nos. 5,132,774 and 5,250,468)			
OD	•	3-133131	06/06/1991	Japan (with partial English translation)			X
N	١.	6-350083	12/22/1994	Japan (with partial English translation)			X
170	*	7-161952	06/23/1995	Japan (with partial English translation)			Х

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

99	1)	European Search Report dated September 30, 1998 for EP 98 11 1608	
	i		

Examiner	Date Considered 6/29/03	

Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

				Sheet <u>1</u> of <u>1</u>
FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE	ATTY, DOCKET NO.	SERIAL NO	
(Rev. 2-32)	PATENT AND TRADEMARK OFFICE	YAO-3950	09/103,873	
Info	ormation Disclosur 1 P	Applicant		
	ement by Applicant	Yoshihisa Nagano et al.		
(Use	several sheets if n cessMAR 1 5 2000	FILING DATE	GROUP	
		June 24, 1998	2815	
	PANGUAR!			

U.S. PATENT DOCUMENTS

Exmr Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
M2	5,344,797	09/06/1994	Pai et al.			
18V	5,374,578	12/20/1994	Patel et al.			
//1/	5,429,840	08/08/1995	Jones, Jr., et al.			
120	5,503,882	04/02/1996	Dawson			
192	5,523,595	06/04,1996	Takenaka et al.			
192	5,650,359	07/22,1997	Ahlburn			
10	5,747,830	05/05/1998	Okita			
122	5,815,223	09/29/1998	Watanabe et al.			
199	5,872,401	02/16/1999	Huff et al.			

FOREIGN PATENT DOCUMENTS

Exmr Initial	Document Number	Date	Country	Class	Sub Class	Translation YES NO
OV	 6-291317	10/18/1994	Japan (with English abstract)			
-						
ļ.,		·			•	<u> </u>
	 /					

OTHER DOCUMENTS

<u> </u>	(Including Author, Title, Date, I	<u> </u>
1	1) S. Wolf Ph.D., et al., "Silicon Processing fo	r the VLSI Era", PROCESS TECHNOLOGY,
[8]	Volume 1, pp. 189-191, 7/22/99	
- Ur		
i		

6/29/00 Date Considered Examiner

Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.